IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Tikashi AKATSU *et al.*

Confirmation No.: 2653

Application No: 10/663,917

Group Art Unit: 2811

Filing Date: September 17, 2003

Examiner: Not Assigned

For: WAFER WITH A RELAXED USEFUL LAYER AND METHOD OF FORMING THE WAFER

Attorney Docket No.: 4717-8900

THIRD INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Arlexandria, Virginia 22313-1450

Sir:

Pursuant to Applicant's duty of disclosure under 37 C.F.R. § 1.56, enclosed is a Form PTO-1449 which lists one (1) references for the Examiner's review.

It is respectfully requested that the references be made of record in this application by the Examiner's completion and return of the attached Form PTO-1449.

Please charge the $180.00 filing fee due for submission of this IDS to Winston & Strawn LLP deposit account no. 50-1814. A duplicate copy of this sheet is enclosed.
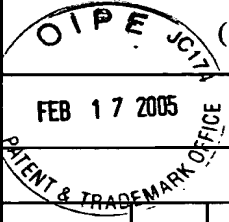
Respectfully submitted,

Feb. 17, 2005
Date

E. Bradley Gould   (Reg. No. 41,792)
For: Allan A. Fanucci   (Reg. No. 30,256)

WINSTON & STRAWN LLP
Customer No. 28765

202-371-5771

		LIST OF REFERENCES CITED BY APPLICANT Form PTO-1449 *(Use several sheets if necessary)*		ATTY. DOCKET NO.: **4717-8900**	APPLICATION NO.: **10/663,917**		
				APPLICANT: **Tukeshi AKATSU** *et al.*			
		Sheet 1 of 1		FILING DATE: **February 17, 2005**	GROUP: **2811**		
		U.S. PATENT DOCUMENTS					
*EXAMINER INITIAL	CITE NO.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A1	6,756,286	Jun 2004	Moriceau et al.	438	459	
	A2						

EXAMINER	DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with **MPEP 609**. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

DC:402358.1